



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Application Number : 10/800,704 Confirmation No. 1758
Applicant : Chan Woo PARK et al.
Filed : March 16, 2004
Tech Cntr/AU : 2823
Examiner : Michelle Estrada
Entitled : METHOD OF MANUFACTURING NANO-GAP ELECTRODE
DEVICE
Attorney Reference : 123034-05004790
Customer Number : 43569

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Entered
By
RCE
5-10-06
VLS

RESPONSE UNDER 37 C.F.R. § 1.116

Sir:

In response to the Final Office Action dated January 10, 2006 for the above-identified application, amendments and/or remarks submitted herewith include:

- A complete claim listing; and
- Remarks and arguments.

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4/18/06